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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/804,707	03/19/2004	Michael Maschke	P04,0086	7519
7590	11/10/2010		EXAMINER	
SCHIFF HARDIN LLP Patent Department 6600 Sears Tower 233 South Wacker Drive Chicago, IL 60606			CHAO, ELMER M	
			ART UNIT	PAPER NUMBER
			3777	
			MAIL DATE	DELIVERY MODE
			11/10/2010	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Examiner-Initiated Interview Summary	Application No.	Applicant(s)	
	10/804,707	MASCHKE, MICHAEL	

Examiner	Art Unit	
ELMER CHAO	3777	

All Participants:

Status of Application: _____

(1) ELMER CHAO.

(3) _____.

(2) Steven H. Noll.

(4) _____.

Date of Interview: 25 October 2010

Time: 2:45pm

Type of Interview:

Telephonic
 Video Conference
 Personal (Copy given to: Applicant Applicant's representative)

Exhibit Shown or Demonstrated: Yes No

If Yes, provide a brief description: _____.

Part I.

Rejection(s) discussed:

Claims discussed:

1, 4

Prior art documents discussed:

Part II.

SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED:

Examiner proposed amending the application to include claim 4. Applicants did not agree to at this time.

Part III.

It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.
 It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.

/Tse Chen/
Supervisory Patent Examiner, Art Unit 3777
/Elmer Chao/
Examiner, Art Unit 3777

(Applicant/Applicant's Representative Signature – if appropriate)